

FORM PTO-1449 (MODIFIED)

ATTORNEY DOCKET NO.

SERIAL NO.

LIST OF PATENTS AND
PUBLICATIONS
FOR APPLICANTS INFORMATION
DISCLOSURE STATEMENT

SP00-383A

APPLICANT Heibel et al.

FILING DATE

GROUP:

10/08/059
U.S. PTO
11/13/01

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
JM	AA	3,167,499	1/26/65	Haresnape			
JM	AB	3,507,627	4/21/70	Frant et al.			
AC							
AD							
AE							
AF							
AG							
AH							
AI							
AJ							
AK							

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
JM	AL	94/09901	5/11/94	World			
AM							
AN							
AO							
AP							
AQ							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

AR	
AS	
AT	
AU	
AV	
AW	

EXAMINER:

Jennifer A. Leung

DATE CONSIDERED:

7-12-2003

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609: draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449 (MODIFIED) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANTS INFORMATION O 1 P 5 DISCLOSURE STATEMENT NOV 04 2002 U.S. PATENT AND TRADEMARK OFFICE	ATTORNEY DOCKET NO. SP00-383A	SERIAL NO. 10/008059
	APPLICANT Heibel et al.	
	FILING DATE: November 13, 2001	GROUP: 1754 1764

REFERENCE DESIGNATION		U.S. PATENT DOCUMENTS					
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						NOV 07 2002
	AH						
	AI						TC 1700
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

<u>JAL</u>	AR	"Process Intensification in in-line monolithic reactor", A. Stankiewicz, <i>Chemical Engineering Science</i> 56 (2001) 359-364.
	AS	
	AT	
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EXAMINER: _____

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JAN 29 2003

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1764

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date if Approp.
JAL	AA	4,335,023	6/15/82	Dettling et al.			
JAL	AB	4,859,642	8/22/89	Hoelderich et al.			
AC							
AD							
AE							
AF							
AG							
AH							
AI							
AJ							
AK							

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TC 1700

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub-Class	Translation Yes No
JAL	AL	02/051532	4/4/02	WO			
JAL	AM	42 43 424	6/23/94	DE			x
AN							
AO							
AP							
AQ							

OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

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